

SURFACE IMPRINTED FILMS WITH CARBON NANOTUBES

STATEMENT REGARDING FEDERALLY SPONSORED RESEARCH OR DEVELOPMENT

5 The invention described herein may be manufactured and used by or for the government of the United States of America for governmental purposes without the payment of any royalties thereon or therefor.

FIELD OF THE INVENTION

10 The present invention relates to apparatus and methods of surface imprinting films, and more specifically, films surface imprinted with nanometer-sized particles including multi-walled carbon nanotubes (MWNT) for military, commercial and recreational applications including, but not limited to, photovoltaic devices.

BACKGROUND OF THE INVENTION

15 There is an ongoing worldwide effort within the field of nanotechnology to shrink the feature sizes of present devices thus leading to improved devices that have lower mass and volume. There is great interest in new processes for production of nanoscale features. Important new processes being developed are methods known as nano-
20 imprinting lithography (NIL) and molecular imprinting (MI). In NIL, basically, a silicon wafer bearing a pattern produced by electron-beam lithography is used to imprint the pattern into a soft polymer film. Typically, in the molecular imprinting processes, a cross-linking polymerization of a mixture of a molecule of interest, a monomer and

porogen is performed, followed by extraction of the molecule of interest, which leaves a porous polymer with imprints of the molecule of interest over its surface.

Efficient fabrication of integrated circuits requires reliable, high-throughput processing to form device elements and interconnects. The most successful patterning technique used over the past several decades has been photolithography, although
5 developments in this technique have pushed feature resolution to the 100 nm range and have come at the expense of increasingly complex and costly fabrication equipment. To address these problems, significant effort has been placed on developing alternative methods of nanoscale patterning, including electron-beam and nanoimprint lithography.

10 Nano-imprinting lithography (NIL), proposed in 1995, is an especially interesting approach for nanoscale pattern generation since it is in principle scalable, parallel, and cost-effective. NIL has been used most widely for creating features with a resolution of 100 nm.

In NIL, a resist relief pattern is generated via compression molding (or
15 embossing) of a deformable polymer by a hard inorganic stamp, rather than by modifying the resist chemical structure with radiation or self-assembly. This pattern is typically transferred to the underlying substrate by anisotropic reactive ion etching (RIE), followed by material deposition and liftoff of the remaining polymer. In general, polymers used for NIL must be heated above the glass transition temperature (ca. 200 °C) to enable flow
20 during the imprinting step. This heating process limits the application of NIL to flexible plastic substrates envisioned for a broad range of emerging applications, since many of these plastics deform at elevated temperatures. Interestingly, recent studies have reported room-temperature nanometer-scale imprinting of polymers on silicon substrates, although

the procedures were not elaborated by subsequent etching and deposition. (Khang, et al., *Adv. Mater* 2001, 13, 749; and Behl, et al., *Adv. Mater* 2002, 14, 588.)

Since imprint lithography is not based on modification of resist chemical structure by radiation, its resolution is immune to many factors that limit the resolution of conventional lithography, such as wave diffraction, scattering and interference in a resist, backscattering from a substrate, and the chemistry of resist and developer.

Molecularly imprinting polymers (MIPs) are of growing interest for their potential application for advanced materials for solid-phase extraction and thin coatings for sensor devices. In most cases, the templates used for the synthesis of imprinted polymers are subnanometer molecules, including solvents, toxic components, or drugs.

Fabrication of microfluidic devices presents new challenges for micro- and nano-engineering. Compared to silicon-based electronic devices, microfluidic devices are much more diverse because of the large variety of fluids, bio-materials and chemicals in use. The reduction in sizes and volumes in miniaturized biological and chemical analysis systems, or so-called "lab-on-a-chip" devices, is leading to drastic improvements in efficiency and throughput. Clearly, for many applications, cheap disposable devices fabricated on bio-compatible substrates of different surface properties are greatly sought after, and low-cost alternatives to the silicon-based micro-electro-mechanical systems (MEMS) technologies based on polymers are highly desirable.

Current solar cells include thin layers of an electrode that sandwich polymer composite sheets. When sunlight hits the sheets, they absorb photons, exciting electrons in the polymer and the molecule of interest, which makes up about 90% of the composite. The result is a useful current that is carried away by the electrodes.

U.S. Pat. No. 6,517,995 issued on February 11, 2003 to Jacobson et al., that teaches an elastomeric stamp, which facilitates direct patterning of electrical, biological, chemical, and mechanical materials. A thin liquid film is patterned by embossing with a patterned elastomeric stamp. The patterned liquid is then cured to form a functional layer.

5 This technique is limited in that it requires a elastomeric stamp and thus the degree to which the relative geometry of nanoscale components are in registry is limited by the ability to position the stamp from layer to layer.

From the foregoing, it will be appreciated that there is a need in the art to develop micro- and nano-structured electron and hole collecting interfaces for fabrication of low mass, low volume, nanofluidic devices and a variety of thin-film electronic devices. The present invention is directed to overcoming one, or more, of the problem set forth above.

SUMMARY OF THE INVENTION

The present invention relates to films surface imprinted with nanometer-sized particles to produce micro- and/or nano-structured electron and hole collecting interfaces.

Embodiments of this aspect of these films include: at least one transparent substrate; at least one photoabsorbing conjugated polymer applied on a first substrate, wherein the conjugate polymer includes polybutylthiophene (pbT); a sufficient amount of nanometer-sized particles including multiwalled carbon nanotubes (MWNT) to produce a charge separation interface; at least one transparent polymerizable layer including a sol-gel or monomer, wherein the MWNT are embedded in the conjugated polymer to produce a mixture and applied on a second substrate to form a MWNT bearing surface film layer to form a stamp surface; wherein the stamp surface is imprinted into the surface of the

polymerizable film layer to produce micro- and/or nano-structured electron and hole collecting interfaces; polymerizing the polymerizable film layer to promote shrinkage to form a conformal gap between the MWNT stamp surface and the surface of the polymerizable film layer; and filling the gap with at least one photoabsorbing material to
5 promote the generation of photoexcited electrons and transport to the charge separation interface.

The films surface imprinted with MWNT further includes compressing and thereafter, solidifying said MWNT stamp surface into the surface of the polymerizable layer. In other embodiments at least one photoabsorbing conjugated polymer include
10 polybutylthiophene (pbT) and the nanometer-sized particles include multiwalled carbon nanotubes (MWNT).

Embodiments of the present invention depend upon knowledge of the compatible thermal properties of carbon nanotubes and sol-gel films and/or monomer films. Instead, others have sought to use highly structured interfaces in photovoltaic devices, but none
15 have taken the approaches described in the present invention.

It is to be understood that the foregoing general description and the following detailed description are exemplary and explanatory only and are not to be viewed as being restrictive of the present invention, as claimed. These and other objects, features and advantages of the present invention will become apparent after a review of the
20 following detailed description of the disclosed embodiments and the appended claims.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1A is a cross sectional view illustrating the films showing the arrangement of

MWNT's embedded in the conjugated polymer according to embodiments of the present invention.

FIG. 1B is a cross sectional view illustrating the orientation of the films while during compression and imprinting according to embodiments of the present invention.

5 **FIG. 1C** is a cross sectional view illustrating the polymerization of the films showing desired shrinkage of both films in the form of the stamp surface of the MWNT's according to embodiments the present invention.

FIG. 2 is a cross sectional view of the films imprinted with MWNT's in a photovoltaic device according to the present invention.

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DETAILED DESCRIPTION OF THE EMBODIMENTS

The present invention relates to films surface imprinted with nanometer-sized particles to produce micro- and/or nano-structured electron and hole collecting interfaces.

One aspect of the present invention in **Figures 1A-C** includes films **10** surface
15 imprinted with nanometer-sized particles prepared by a process to produce micro- and/or nano-structured electron and hole collecting interfaces, including: providing at least one transparent substrate **14**; providing at least one photoabsorbing conjugated polymer **16**; providing a sufficient amount of nanometer-sized particles **12** to produce a charge separation interface; providing at least one transparent polymerizable layer **18** including a
20 sol-gel or monomer; embedding the nanometer-sized particles **12** in the conjugated polymer **16**; applying the polymerizable layer **18** on a first substrate **14** to form a charge transport film layer; applying the conjugated polymer/nanometer-sized particle mixture on a second substrate **14** to form a nanometer-sized particles bearing surface film layer, wherein the

nanometer-sized particles form a stamp surface; imprinting the stamp surface into the surface of the polymerizable film layer to produce micro- and/or nano-structured electron and hole collecting interfaces; polymerizing the polymerizable film layer **18** to promote shrinkage to form a conformal gap **26** between the stamp surface and the surface of the polymerizable film layer **18**; and filling the gap **26** with at least one photoabsorbing material to promote the generation of photoexcited electrons **28** and transport to the charge separation interface.

Another aspect of the present invention includes films **10** surface imprinted with nanometer-sized particles to produce micro- and/or nano-structured electron and hole collecting interfaces, including: at least one transparent substrate **14**; at least one photoabsorbing conjugated polymer **16** applied on a first substrate **14**, wherein the conjugate polymer **16** includes polybutylthiophene (pbT); a sufficient amount of nanometer-sized particles including multiwalled carbon nanotubes (MWNT) **12** to produce a charge separation interface; at least one transparent polymerizable layer **18** including a sol-gel or monomer, wherein the MWNT **12** are embedded in the conjugated polymer to produce a mixture and applied on a second substrate **14** to form a MWNT bearing surface film layer to form a stamp surface; wherein the stamp surface is imprinted into the surface of the polymerizable film layer **18** to produce micro- and/or nano-structured electron and hole collecting interfaces; polymerizing the polymerizable film layer **18** to promote shrinkage to form a conformal gap **26** between the MWNT stamp surface and the surface of the polymerizable film layer **18**; and filling the gap **26** with at least one photoabsorbing material to promote the generation of photoexcited electrons **28** and transport to the charge separation interface.

A further aspect of the present invention includes films 10 surface imprinted with nanometer-sized particles to produce micro- and/or nano-structured electron and hole collecting interfaces, including: at least one transparent substrate 14; at least one photoabsorbing conjugated polymer 16 applied on a first substrate 14, wherein the conjugate
5 polymer 16 includes polybutylthiophene (pbT); a sufficient amount of nanometer-sized particles including multiwalled carbon nanotubes (MWNT) 12 to produce a charge separation interface; at least one transparent polymerizable layer 18 including a polymer, wherein the MWNT 12 are embedded in the conjugated polymer to produce a mixture and applied on a second substrate 14 to form a MWNT bearing surface film layer to form a
10 stamp surface; wherein the stamp surface is imprinted into the surface of the polymerizable film layer 18 to produce micro- and/or nano-structured electron and hole collecting interfaces; polymerizing the polymerizable film layer 18 to promote shrinkage to form a conformal gap 26 between the MWNT stamp surface and the surface of the polymerizable film layer 18; and filling the gap 26 with at least one photoabsorbing material to promote the
15 generation of photoexcited electrons 28 and transport to the charge separation interface.

Yet another aspect of the present invention includes a method of making films surface imprinted with nanometer-sized particles to produce micro- and/or nano-structured electron and hole collecting interfaces. Embodiments of the method of making these films include: providing at least one transparent substrate, providing at least one photoabsorbing
20 conjugated polymer, providing a sufficient amount of nanometer-sized particles to produce a charge separation interface, providing at least one transparent polymerizable layer including a sol-gel or monomer, embedding the nanometer-sized particles in the conjugated polymer, applying the polymerizable layer on a first substrate to form a charge transport film layer,

applying the conjugated polymer/nanometer-sized particle mixture on a second substrate to form a nanometer-sized particles bearing surface film layer, wherein the nanometer-sized particles form a stamp surface, imprinting the stamp surface into the surface of the polymerizable film layer to produce micro- and/or nano-structured electron and hole
5 collecting interfaces, polymerizing the polymerizable film layer to promote shrinkage to form a conformal gap between the stamp surface and the surface of the polymerizable film layer, and filling the gap with at least one photoabsorbing material to promote the generation of photoexcited electrons and transport to the charge separation interface.

The methods of imprinting further include compressing and thereafter, solidifying
10 the MWNT stamp surface into the surface of the polymerizable layer. In other embodiments at least one photoabsorbing conjugated polymer include polybutylthiophene (pbT) and the nanometer-sized particles include multiwalled carbon nanotubes (MWNT). The films surface imprinted with nanometer-sized particles are obtained by the process defined above.

15 Embodiments of the present invention having substrates include at least one of silicon, silicate, plastic, and plastic-like materials. The substrate in other embodiments acts as an electrode by including a coating of at least one transparent metal oxide including $\text{SnO}_2\text{:F}$, $\text{SnO}_2\text{:In}$ (ITO), and Au. In other embodiments, the substrate substrate acts as an electrode by including a coating of at least one transparent metal oxide being conducting
20 polymers including polythiophenes, polypyrroles, polyanilines, and polybutylthiophenes.

Embodiments of the present invention include both the conjugated polymer/nanometer-sized particle mixture on a second substrate to form a nanometer-sized particles bearing surface film layer and the polymerizable layer on a first substrate to form a

charge transport film layer being applied by processes comprising at least one of spin-coating, dip-coating, spray-coating, flow-coating, doctor blade coating, and screen-printing.

One skilled in the art is knowledgeable in the above processes in applying solutions to specific substrates identified in the present invention. The conjugated polymer includes pbT
5 dissolved in chlorobenzene.

The polymerizable layer includes at least one polymer, monomer, or a sol-gel. The polymerizable layer having sol-gels includes absolute alcohol and ultrapure water in a ratio of about (1:0.025) and said metal oxide includes titanium oxide and/or zinc oxide. The metal oxide includes at least one of inorganic metal salts and metal organic compounds.

10 The metal organic compounds include metal alkoxides including at least one of titanium isopropoxide and zinc butoxide. The polymerizable layer having monomers includes a monomer comprising at least one of oxadiazole, aniline, and pyrrole. The polymerizable layer having polymers comprising at least one of nitrogen including heterocycle(s) and/or polyanilines. When applying the polymerizable film layer on the substrate, the thickness of
15 the layer ranges from about 1 nm to about 1 mm. When applying the conjugated polymer mixture on a separate substrate, the thickness of the layer ranges from up to about 100 nm.

The nanometer-sized particles include, but are not limited to, at least one of MWNT, single-walled carbon nanotubes (SWNT), and nanocrystals of semiconductor materials. The nanocrystals of semiconductor materials include, but not limit to, at least one of CdSe, metal
20 nanowires, and metal-filled carbon nanotubes. The nanometer-sized particles include average particle sizes of about 1 nm to about 100 nm in diameter and up to about 1 nm to about 1 cm in length. In other embodiments the nanometer-sized particles include average particle sizes of about 1 nm to about 100 nm in diameter and up to about 1 nm to about 500

nm in length. The photoabsorbing material includes at least one of thermotropic liquid crystalline materials, polybutylthiophene (pbT)/chlorobenzene, and polyelectrolytes.

The term “nanometer-sized particle” is defined to include objects or particles of a compound, element, or composition ranging in size from about 1 nanometer to about 100
5 nanometers in size. The process that produces “metal-filled carbon nanotubes” includes, but is not limited to, the following process. The introduction of metals or metal carbide and oxides into multiwalled carbon nanotubes significantly alter their conducting, electronic, and mechanical properties, arising from the internal framework within these structures. The metal-filled carbon nanotubes have a variety of industrial applications
10 including catalysts, electronic devices, magnetic tape, and biosensors. (Bao, et al, APPLIED PHYSICS LETTERS VOLUME 81, NO. 24, 9 DEC 2002, 4592-4595.)

The following examples include film fabrication processes having a first substrate bearing carbon nanotubes (CNT's) or multiwalled carbon nanotubes (MWNT's) attached or embedded into its surface which is imprinted into a metal oxide sol-gel or imprintable
15 monomer surface followed by a polymerization process. In other embodiments, polymerization shrinkage is desirable to open a conformal gap between the CNT bearing stamp surface and the opposing sol-gel or monomer film surface. The conformal gap between the CNT bearing surface and the TiO₂ bearing surface was back-filled with a photoabsorbing polymer solution using capillary action. In other embodiments,
20 thermotropic liquid crystalline materials are utilized in the back-filling procedure above due to the neat liquid crystalline heated to its isotropic phase will fill the conformal gap uniformly, and completely, in one application.

The present invention will now be explained with references to the following non-limiting examples.

EXAMPLES

Substrates were prepared and cleaned. The preparation of the Sol-gel and
5 conjugated polymer solutions were formulated and desired micro- and nano-structured molecules were dispersed in these solutions.

Substrates chosen for this embodiment were fluorine-doped tin oxide (SnO₂:F) coated glass purchased from Hartford Glass cut to size 3 inches by 1 inch. The substrates were cleaned by immersion in dilute alconox solution (detergent) at 50 °C for 1 hour,
10 followed by rinsing with ultrapure water (17.9 Mega Ohm resistivity), isopropanol, chloroform, and absolute ethanol (absolute being 200 proof).

The sol-gel solution was prepared by mixing 9.8 mL ethanol (100%), 250 μ L ultrapure H₂O, and 1 drop of concentrated nitric acid (HNO₃) in a vial. It was desirable to include an alcohol and water mix ratio of about (1:0.025). Nitric acid was utilized for
15 acidification of the alcohol/water mix. The vial was then transferred to a glove-box purged with N₂ gas for approximately 1 to 2 hours for the desired preservation and storage of the mixture. Under N₂ in a glove-box, 1 mL of titanium isopropoxide chloride was added to make a conducting oxide (titanium oxide) mixture. The choice of metal oxides including titanium oxide (Gelest) and zinc oxide depends upon the compatible
20 thermal properties of CNT and the curing temperature of the sol-gel films. The solution was stirred continuously with a magnetic stirrer for at least 1 hour to promote a homogeneous mixture.

The conjugated polymer solution was formulated by dissolving 1 mg of a

conjugated polymer polybutylthiophene (pbT) from Aldrich in 3 mL of chlorobenzene and filtered through a 0.4 micrometer pore size membrane filter. Approximately 1.5 mg of multiwalled carbon nanotubes (MWNT) were dispersed into the pbT/chlorobenzene mixture and sonicated for 2 hours. MWNT's utilized were produced by an in-house arc
5 discharge process. The average particle size was approximately 12 nm in diameter and 140 nm in length.

A technique known in the art as "spin-coating" was utilized in this embodiment of the present invention to form a film layer of sol-gel or conjugated polymer on or onto the glass substrate. A spin-coating technique was utilized to apply the sol-gel solution onto
10 the glass substrate. A few drops of titanium isopropoxide sol-gel solution was placed on the clean substrate then spun at 1000 rpm for 1 minute. After the sol-gel was spin-coated onto the substrate, the sol-gel film layer was solidified at 500 °C for 30 minutes. The spin-coating technique was used again to apply the conjugated polymer/MWNT mixture onto a separate glass substrate. While the substrate was spinning at 1000 rpm, 1 mL of
15 the well-dispersed MWNT in pbT was pipetted dropwise at a rate of approximately 1 drop every 3 to 5 seconds. The substrate was allowed to continue spinning for an additional 1 minute at 1000 rpm. The conjugated polymer film was dried in a vacuum oven at 60 °C overnight. The amount of conjugated polymer solution spin-coated on the substrate in other embodiments of the present invention depends on the micro- and nano-
20 structured molecule utilized in the conjugated polymer solution. In these embodiments, a sufficient amount of MWNT/pbT solution utilized permits partial to fully exposed MWNT's to protrude out from the film layer to form an impressible micro- and nano-structured surface.

After the solutions were spin-coated onto their glass substrates, the stamp surface of the conjugated polymer/MWNT film layer was imprinted into the surface of the metal oxide sol-gel film. The substrate with the sol-gel film was placed on a ceramic plate on the floor of a furnace oven at ambient or room temperature with the door open. Room
5 temperature is defined as an indoor temperature of from about 50 °F to about 100 °F. The substrate bearing the MWNT film was dropped from a height of a few millimeters onto the sol-gel film. A 35-gram weight was placed on top of the MWNT bearing substrate to prevent relative lateral movement of the substrates. The furnace oven door was then closed and the films were heated and held at 500 °C for 45 minutes. The
10 ceramic plate carrying the substrates and weight was removed from the furnace and permitted to cool to room temperature. For characterization of the efficacy of the imprinting, some of the samples were split apart and the solidified TiO₂ film was imaged with a Digital Instruments DI3100 Scanning Probe Microscope. The remaining samples were left intact for photovoltaic device testing. The films of the present invention are
15 utilized with photovoltaic devices or other light guiding devices.

Photovoltaic Device Fabrication

A photovoltaic device **20** was completed by filling the space or gap **26** between the substrates **14** by capillary action with a few drops of filtered pbT in chlorobenzene
20 solution (a desirable photo-absorbing polymer solution **16**). The photovoltaic device **20** is constructed of the following components: parafilms **22**, substrates **14**, electrodes with SNO₂:F **24**, sol gel/monomer **18**, and conjugated polymer with MWNT **16**. The photovoltaic device was dried at 60 °C in a vacuum oven overnight before testing.

Figure 2 illustrates the arrangements of the films imprinted with MWNT's in a photovoltaic device.

The photovoltaic device of the present invention was tested and the following evaluations for the photovoltaic device were performed. For all measurements the test
5 photovoltaic device was attached to the measurement equipment using alligator clip jumpers. For voltage measurements, a calibrated Fluke 8840A multimeter (Serial # 3618080) was utilized. For amperes measurements, a Keithley Electrometer was also used. An IR blocking filter was used for all measurements (cut-on 960 nm). The resistance measured through the test photovoltaic device was 1.1 kOhms and the area of
10 the effective device was 600 mm².

For short circuit current, I_{sc} , and open circuit voltage, V_{oc} , measurements, the following tests were achieved by using a 150W Tungsten lamp at approximately 10 cm from the test photovoltaic device. Each measurement performed run a total of 60 seconds. The Tungsten lamp was turned "off" for the following intervals: 0-10, 20-30,
15 40-50, and 55-60 seconds. The Tungsten lamp was turned "on" for the other intervals, 10-20, 30-40, and 50-55 seconds. The test photovoltaic device was successfully illuminated with the TiO₂ polymerizable layer facing the light.

It should be understood that the examples and embodiments described herein are for illustrative purposes only and that various modifications or changes in light thereof
20 will be suggested to persons skilled in the art and are to be included within the spirit and purview of this application and the scope of the appended claims.